



AF/1771
IPW

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Tandy et al.

Serial No.: 10/092,139

Filed: March 6, 2002

For: METHOD AND APPARATUS FOR
MARKING A BARE SEMICONDUCTOR
DIE

Confirmation No.: 9714

Examiner: V. Chang

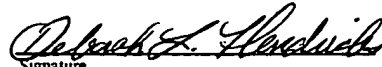
Group Art Unit: 1771

Attorney Docket No.: 2269-4333.1US
(99-0257.01)

CERTIFICATE OF MAILING

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AMENDMENT UNDER 37 C.F.R. §1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
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Sir:

The following amendments and remarks are filed in response to the Examiner's remarks in the Final Office Action mailed October 19, 2004, the three-month shortened statutory period for response to which expires on January 19, 2004. This response is submitted on or before two months from the mailing date of the Final Office Action.

Amendments to the Specification begin on page 3 of this paper.

Amendment to the Drawings begin on page 4 of this paper and include both an attached replacement sheets and annotated sheets showing changes.